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Contents

v Conference Committee

OPTICAL THIN FILM COATINGS

13114 02 Highly stable silver thin films utilizing aluminum nanolayers (Invited Paper) [13114-3]

THIN FILM METAL OXIDE MEMRISTORS

- 13114 03 A computational study of formation of multiple simultaneous conducting filaments in resistive switching thin films (Invited Paper) [13114-6]
- 13114 04 A study on conducting filament formation in varying 3D memristive thin film using a phase-field model [13114-7]

NANOWIRES FOR OPTOELECTRONICS, ENERGY, AND SENSING II

13114 05 Why III-V nanowires can challenge high-efficiency photovoltaic solar cells (Invited Paper) [13114-12]

QUANTUM DOTS AND NANOSTRUCTURES FOR OPTOELECTRONICS I

13114 06 Effect of Zn precursors on the optical properties of indium phosphorus quantum dots [13114-16]

QUANTUM DOTS AND NANOSTRUCTURES FOR OPTOELECTRONICS II

- 13114 07 Exploring surface plasmon nanolaser applications with substrate-free fabrication method (Invited Paper) [13114-21]
- 13114 08 Metasurface-enabled circular light propagation for ultra-fast and efficient photodetection [13114-22]

2D MATERIALS SYNTHESIS I

- 1311409 Molecular decomposition reactions and early nucleation in CVD growth of graphene on Cu and Si substrates from toluene (Invited Paper) [13114-23]
- 13114 0A Atomic layer processing of MoS₂ (Invited Paper) [13114-24]

2D MATERIALS SYNTHESIS II

13114 OB Surface functionalization and atomic layer deposition of metal oxides on MoS₂ surfaces (Invited Paper) [13114-25]

POSTER SESSION

- 13114 0C **Towards on-chip TMD-based light source for silicon-based photonics interconnects** [13114-41]
- 13114 0D Improving optical response and hydrolyzation resistance of silver-based astronomical telescope mirrors via filtered cathodic arc-deposited diamond-like carbon [13114-43]